



JP

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Toru YAMADA

Group Art Unit: 1714

Application No.: 10/582,802

Examiner: G. RAO

Filed: June 14, 2006

Docket No.: 136170

For: VAPOR PHASE GROWTH APPARATUS AND METHOD OF FABRICATING
EPITAXIAL WAFER

SUMMARY OF SUBSTANCE OF INTERVIEW

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant's representative conducted a personal interview on November 10, 2010 with Examiner Song. Applicant appreciates the courtesies shown to Applicant's representative by Examiner Song during the personal interview. Applicant's separate record of the substance of the personal interview is detailed below.

Applicant's representative discussed the October 21, 2010 Amendment with Examiner Song. Applicant's representative pointed out the differences between the pending claims and the currently-applied references. Examiner Song indicated that further search and consideration would be required upon review of the October 21, 2010 Amendment.

Should any questions arise regarding this communication, all inquiries may be directed to Applicant's undersigned representative at the telephone number set forth below.

Respectfully submitted,



William P. Berridge
Registration No. 30,024

Michael J. Steger
Registration No. 66,034

WPB:MJS/aea

Date: November 12, 2010

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